



PATENT AF
RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP: 2811

Art Unit:

2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Masaki Tamaru et al.

Serial No.:

09/616,086

Filed:

July 14, 2000

Title:

"SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME"

Examiner:

Hung K. Vu

Docket No.:

32811

Amendment B

BOX AF AMENDMENTS Commissioner for Patents Washington, D.C. 20231

Sir:

In response to the Office action dated November 19, 2002, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on the date indicated below.

Ronald M. Kachmarik
Name of Attorney for Applicant(s)

10,2003

Date

Signature of Attorney